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Bib Data Sheet

CONFIRMATION NO. 2731

<b>SERIAL NUMBER</b> 09/869,912	<b>FILING DATE</b> 07/09/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 1765	<b>ATTORNEY DOCKET NO.</b> 110051
<b>APPLICANTS</b> Makoto Iida, Gunma, JAPAN; Masanori Kimura, Gunma, JAPAN;  <b>** CONTINUING DATA *****</b> THIS APPLICATION IS A 371 OF PCT/JP00/07809 11/07/2000  <b>** FOREIGN APPLICATIONS *****</b> JAPAN 11-322487 11/12/1999				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Not after Verified and Acknowledged <input checked="" type="checkbox"/> Allowance Examiner's Signature _____ Initials _____	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 1	<b>TOTAL CLAIMS</b> 1	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> Oliff & Berridge PO Box 19928 Alexandria, VA 22320				
<b>TITLE</b> Silicon single crystal wafer and production method thereof and soi wafer				
<b>FILING FEE RECEIVED</b> 878	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	